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S/N 10/692,881PATENTIN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| Applicant: | Sharone Gindel | Examiner: | Saeed T. Chaudhry |
| Serial No.: | 10/692,881 | Group Art Unit: | 1744 |
| Filed: | October 24, 2003 | Docket No.: | 884.422US2 |
| Title: | VACUUM DEBRIS REMOVAL SYSTEM FOR AN INTEGRATED CIRCUIT MANUFACTURING DEVICE | | |
| Assignee: | Intel Corporation | Customer No: | 21186 |

AMENDMENT AND RESPONSE UNDER 37 CFR § 1.111

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

This responds to the Office Action mailed on November 5, 2004. Please amend the above-identified patent application as follows.